

10013103  
11/06/2001

U.S. UTILITY Patent Application

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PATENT NUMBER and  
ISSUE DATE

APPL NUM 10013103	FILING DATE 11/06/2001	CLASS 257 438	SUBCLASS 640	CAJ 2822	EXAMINER Leville
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\*\*APPLICANTS: Seshan Krishna; Dass M.; Bakker Geoffrey;

\*\*CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/105,590 06/26/1998

\*\*FOREIGN APPLICATIONS VERIFIED:

PG-PUB ☐ DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no  
35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

42390P5778D

TITLE : Semiconductor passivation deposition process for interfacial adhesion

U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED

Amount Due Date Paid

Amount Due Date Paid



TERMINAL

DISCLAIMER

Assistant Examiner

Primary Examiner

PREPARED FOR ISSUE

CLAIMS ALLOWED

Total Claims 13  
Print Claim for 0.0

DRIVING

Sheets Drawn 13  
Fig. Drawn 13  
Print Fig. 13

Application Examiner

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